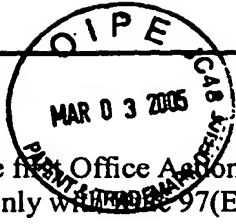


FORM EKC-1449



Atty. Docket No.

86896RLO

Customer No. 01333

Serial No.

10/663,578

If AFTER the later date of the first Office Action or 3 months from filing, use only with Form 97(E) Certificate or Fee

Applicant:

Syamal K. Ghosh, et al

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use several sheets if necessary)

Filing Date

16 September 2003

Group

1762

## U.S. PATENT DOCUMENTS

Examiner Initial*	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JW	3586297	06-22-1971	Hotta	—	—	
JW	2003/099153	05-29-2003	Renfro	—	—	

## FOREIGN PATENT DOCUMENTS

Examiner Initial*	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
JW	549250	11-12-1942	GB	—	—		X
JW	1210299	10-28-1970	GB	—	—		X

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Yudasaka et al, Polyperinaphthalene Film Formation by a Pulsed Laser Deposition With a Target of Perylenetetracarboxylic Dianhydride, Appl. Phys. Letts. Vol. 64, No. 24, pgs. 3237-3239, 6/13/94

EXAMINER

DATE CONSIDERED

2/22/06

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<b>FORM PTO-1449</b> <b>US DEPARTMENT OF COMMERCE</b> <b>PATENT AND TRADEMARK OFFICE</b>		Any. Docket No. <b>86896RLO</b> Customer No. 01333		Serial No. <b>To be assigned</b>	
If AFTER the later date of the first Office Action or 3 months from filing, use only with Rule 97(E) Certificate or Fee		Applicant: <b>Syamal K. Ghosh, et al</b>			
<b>LIST OF ART CITED BY APPLICANT</b> <i>(Use several sheets if necessary)</i>		Filing Date <b>Herewith</b>		Group	

U.S. PATENT DOCUMENTS						
Examiner Initial*	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JW	4356429	10-26-1982	Tang	—	—	
JW	4539507	09-03-1985	Van Slyke et al	—	—	
JW	4720432	01-19-1988	Van Slyke et al	—	—	
JW	4769292	09-06-1988	Tang et al	—	—	
JW	2003/0008071	01-09-2003	Van Slyke et al	—	—	

FOREIGN PATENT DOCUMENTS							
Examiner Initial*	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
<del>JW</del>	<del>02-042421</del>	<del>02-13-1990</del>	<del>Japan</del>	<del>—</del>	<del>—</del>	<del>—</del>	<del>X</del>
JW	11-092915	04-06-1999	Japan	—	—	X	
JW	2000-252061	09-14-2000	Japan	—	—	X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)	
JW	Van Slyke et al, Linear Source Deposition of Organic Layers for Full-Color OLED, SID 02 Digest, pgs. 886-889

EXAMINER	DATE CONSIDERED <b>2/22/06</b>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.